## Armando Arpys Arevalo Carreno

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/2129566/publications.pdf

Version: 2024-02-01

23 papers 364 citations

8 h-index 10 g-index

23 all docs 23 docs citations

times ranked

23

573 citing authors

#	Article	IF	CITATIONS
1	High-Throughput Incubation and Quantification of Agglutination Assays in a Microfluidic System. Genes, 2018, 9, 281.	2.4	10
2	Folding and stretching a thermoelectric generator. , 2018, , .		1
3	3D Printing: Decal Electronics: Printable Packaged with 3D Printing Highâ€Performance Flexible CMOS Electronic Systems (Adv. Mater. Technol. 1/2017). Advanced Materials Technologies, 2017, 2, .	5.8	O
4	Paper-based origami flexible and foldable thermoelectric nanogenerator. Nano Energy, 2017, 31, 296-301.	16.0	125
5	Decal Electronics: Printable Packaged with 3D Printing Highâ€Performance Flexible CMOS Electronic Systems. Advanced Materials Technologies, 2017, 2, 1600175.	5.8	8
6	Comparison of capacitive and radio frequency resonator sensors for monitoring parallelized droplet microfluidic production. Lab on A Chip, 2016, 16, 3210-3219.	6.0	9
7	A study of the incubation of microbead agglutination assays in a microfluidic system. , 2016, , .		O
8	Capacitive sensor for continuous monitoring of high-volume droplet microfluidic generation. , 2016, , .		2
9	Piezoelectric transducer array microspeaker. , 2016, , .		3
10	Digital electrostatic acoustic transducer array. , 2016, , .		3
11	Radio frequency feedback method for parallelized droplet microfluidics. , 2016, , .		4
12	MEMS digital parametric loudspeaker. , 2016, , .		3
13	An Experimental and Theoretical Investigation of a Micromirror Under Mixed-Frequency Excitation. Journal of Microelectromechanical Systems, 2015, 24, 1124-1131.	2.5	30
14	Outâ€ofâ€plane buckled cantilever microstructures with adjustable angular positions using thermal bimorph actuation for transducer applications. Micro and Nano Letters, 2015, 10, 545-549.	1.3	7
15	Out-of-plane platforms with bi-directional thermal bimorph actuation for transducer applications. , 2015, , .		5
16	Torsion based universal MEMS logic device. Sensors and Actuators A: Physical, 2015, 236, 150-158.	4.1	24
17	Towards a digital sound reconstruction MEMS device: Characterization of a single PZT based piezoelectric actuator., 2015,,.		7
18	A versatile multi-user polyimide surface micromachinning process for MEMS applications. , 2015, , .		28

#	Article	IF	CITATIONS
19	Low-cost silicon wafer dicing using a craft cutter. Microsystem Technologies, 2015, 21, 1411-1414.	2.0	9
20	Design and characterization of ultra-stretchable monolithic silicon fabric. Applied Physics Letters, 2014, 105, .	<b>3.</b> 3	56
21	Three-Axis Magnetic Field Induction Sensor Realized on Buckled Cantilever Plate. IEEE Transactions on Magnetics, 2013, 49, 4144-4147.	2.1	18
22	Simulation of a Low Frequency Z-Axis SU-8 Accelerometer in CoventorWare and MEMS+., 2013,,.		5
23	Simulation of SU-8 Frequency-Driven Scratch Drive Actuators. , 2013, , .		7